



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/542,378
Applicant : Kun Hong LEE et al.
Filed : July 14, 2005
TC/A.U. : 2879
Examiner :

Docket No. : 1751-386
Customer No. : 06449
Confirmation No. : 3447

INFORMATION DISCLOSURE STATEMENT

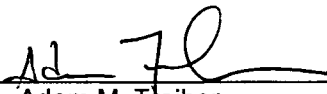
Director of the United States Patent
and Trademark Office
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

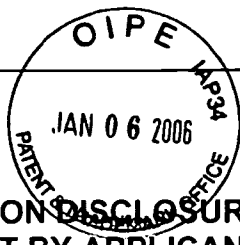
Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant submits herewith
information that the Office may wish to consider in examination of the subject application.

Materials submitted for consideration are listed on the attached form PTO-1449.

Respectfully submitted,

By 
Adam M. Treiber
Attorney for Applicants
Registration No. 48,000
ROTHWELL, FIGG, ERNST & MANBECK, p.c.
Suite 800, 1425 K Street, N.W.
Washington, D.C. 20005
Telephone: (202)783-6040

Enclosure(s): (4) Cited References



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

<p align="center"><i>Complete if Known</i></p>					
				Application Number	10/542,378
				Filing Date	July 14, 2005
				First Named Inventor	Kun Hong LEE et al.
				Group Art Unit	2879
				Examiner Name	
Confirmation No.				3447	
Sheet	1	of	1	Attorney Docket Number	1751-386

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code ² (if known)		

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office ³ Code	Number ⁴	Kind ⁵ (if known)			
/MStgo/	1	JP	10-199398	A	RICOH CO LTD	07-31-1998	AB
/MStgo/	2	JP	10-199400	A	FUTABA CORP	07-31-1998	AB
/MStgo/	3	KR	1020020041664	A	LG ELECTRONICS INC. and POSTECH FOUNDATION	06-03-2002	AB
/MStgo/	4	KR	1020020041665	A	LG ELECTRONICS INC. and POSTECH FOUNDATION	06-03-2002	AB
Examiner Signature		/Mariceli Santiago/			Date Considered	06/09/2008	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.